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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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MORITA, et al.

Serial No.: 10/628,690

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Group: 1765

Examiner: Song, Matthew J.

Attorney Docket No.: JG-SU-5004C/500577.20052

A METHOD OF MANUFACTURING SILICON

MAIL STOP Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 **CUSTOMER NO. 026418** 

## **RESPONSE TO THE OFFICE ACTION**

Dear Sir:

In response to the Office Action mailed February 4, 2005, it is respectfully requested that the following amendments be entered and the accompanying remarks be considered. The two (2) month shortened statutory period for response is set to expire July 4, 2005. Therefore, a petition for and the requisite fee for a one-month extension of time are filed herewith. Accordingly, this response is timely filed.

Amendments to the Claims are reflected in the listing of claims, which begins on page 2 of this paper. Remarks begin on page 2 of this paper.

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